

L Number	Hits	Search Text	DB	Time stamp
1	148000	(spectral or spectrum ) and filter	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/11 18:17
2	2107	(spectral or spectrum ) and filter and (stray adj3 light)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/11 18:18
3	4189	filter and (stray adj3 light)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/11 18:18
4	20	filter and (stray adj3 light) and GaN	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/11 18:20
5	855	372/108.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/09/11 18:20
-	56	372/108.ccls. and ( Filter and (hole or opening))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 12:52
-	0	372/108.ccls. and ( Filter and (hole or opening) and GaN near3 semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 12:52
-	0	372/108.ccls. and ( Filter and (hole or opening) and GaN )	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 12:53
-	28	372/108.ccls. and ( Filter and (hole or opening) and semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 12:54
-	45	372/108.ccls. and ( Filter and (hole or opening or aperture) and semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 12:55
-	33498	( Filter and (hole or opening or aperture) and semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 12:56
-	99	( Filter and (hole or opening or aperture) and GaN near3 semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 12:56
-	1	( Filter and (hole or opening or aperture) and GaN near3 semiconductor) and stray near3 light and (drive near3 current)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 12:56
-	3	( Filter and (hole or opening or aperture) and GaN near3 semiconductor) and stray near3 light	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:01
-	1672	372/99,101,103.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:05
-	3433	372/46,107.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:06
-	100	372/46,107.ccls. and ( Filter and (hole or opening or aperture) and semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:06

-	107	372/99,101,103.ccls. and ( Filter and (hole or opening or aperture) and semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:12
-	33498	( Filter and (hole or opening or aperture) and semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:13
-	5309	( Filter and (hole or opening or aperture) and semiconductor near3 laser)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:13
-	5637	(Filter and (slit or hole or opening or aperture) and semiconductor near3 laser)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:13
-	4015	(Filter and (slit or hole or opening or aperture) and semiconductor near3 laser) and ( reduce or eliminate)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:14
-	223	(Filter and (slit or hole or opening or aperture) and semiconductor near3 laser) and ( reduce or eliminate) and stray near3 light	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:14
-	453	(Filter and (slit or hole or opening or aperture) and semiconductor near3 laser) and ( reduce or eliminate) and ((stray near3 light) or (fluctuate))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:15
-	396	(Filter and lens and (slit or hole or opening or aperture) and semiconductor near3 laser) and ( reduce or eliminate) and ((stray near3 light) or (fluctuate))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:15
-	2920	(beam near3 control or (beam near3 focus)) and Filter and (slit or hole or opening or aperture) and semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:39
-	79	(beam near3 control or (beam near3 focus)) and ( (Filter and (slit or hole or opening or aperture) and semiconductor near3 laser) and ( reduce or eliminate) and stray near3 light)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:44
-	823	372/108.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/24 13:49
-	2065	GaN near3 (semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/28 12:09
-	163	GaN near3 (semiconductor) and filter	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/28 12:10
-	1143669	GaN near3 (semiconductor) and filter and (stray near3 light) and reduce or reduction	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/28 12:57
-	4	GaN near3 (semiconductor) and filter and (stray near3 light) and (reduce or reduction)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/28 12:58
-	12	GaN and (semiconductor) and filter and (stray near3 light) and (reduce or reduction)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/28 13:26